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# **Use of Self-Assembled Monolayers and Light to Tailor Adhesion on Surfaces for Nanomanufacturing Applications**

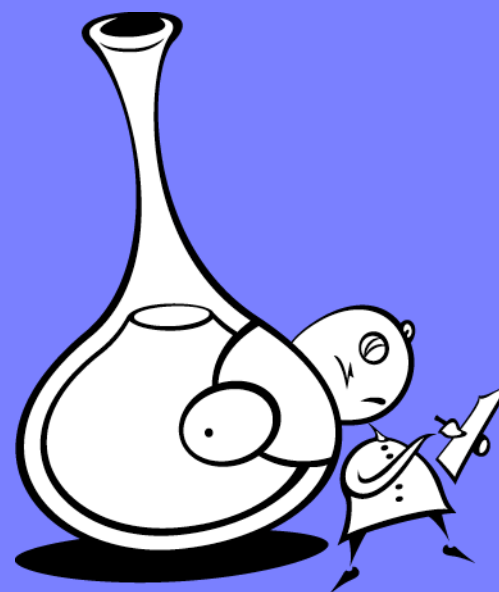
J.E. Whitten

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The University of Massachusetts Lowell  
Lowell, MA 01854

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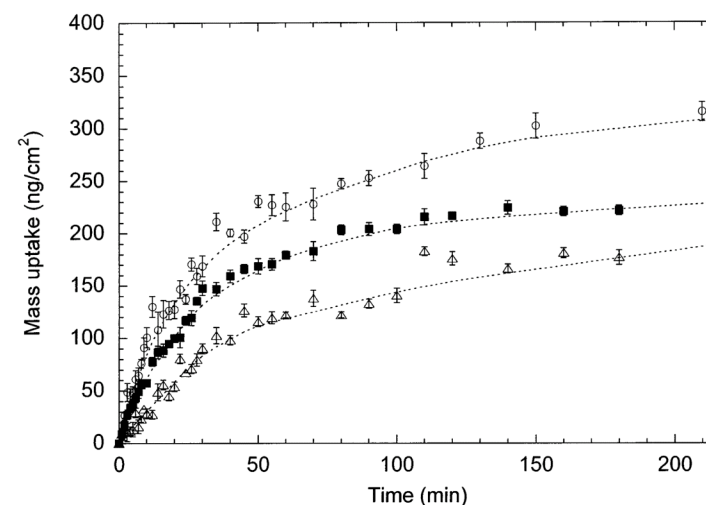
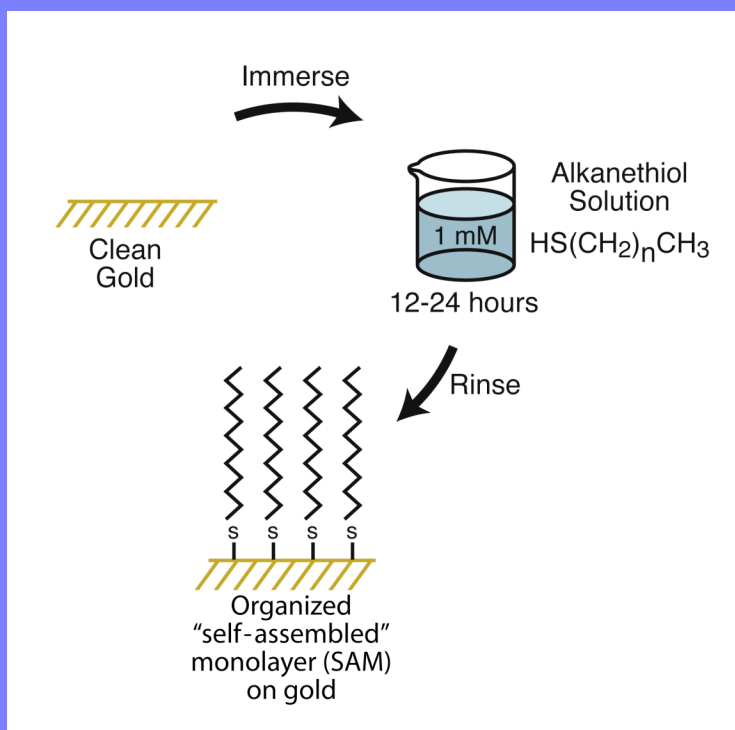
## The Whitten Group

- ❖ Electronic Structure of Conjugated Polymer Films
- ❖ Organic-Metal Interfaces
- ❖ Organic Dye-Inorganic Semiconductor Interfaces
- ❖ Nanopatterning of Materials and Transfer
- ❖ Measurement of Forces between Surfaces
- ❖ Chemical Sensors Based on Gold Nanoparticles
- ❖ Metal Oxide Surface Chemistry
- ❖ Development of Low-Cost Spectroscopy Experiments for Chemical Education - Blue Diode Lasers and Light-Emitting Diodes



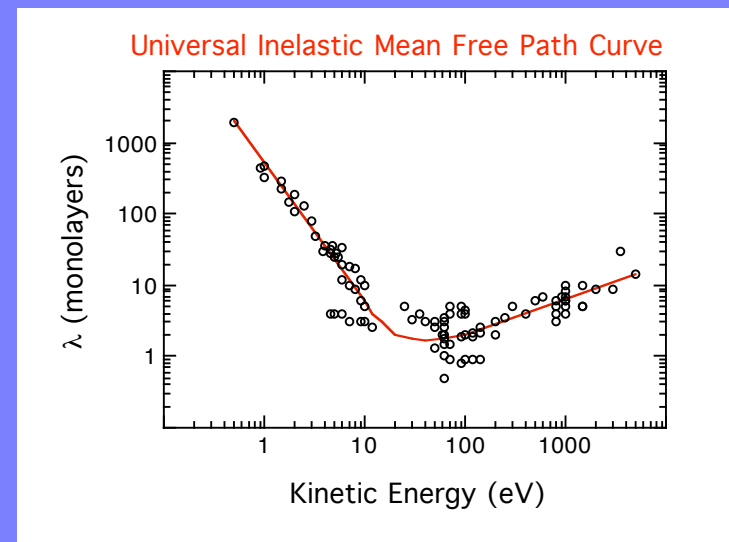
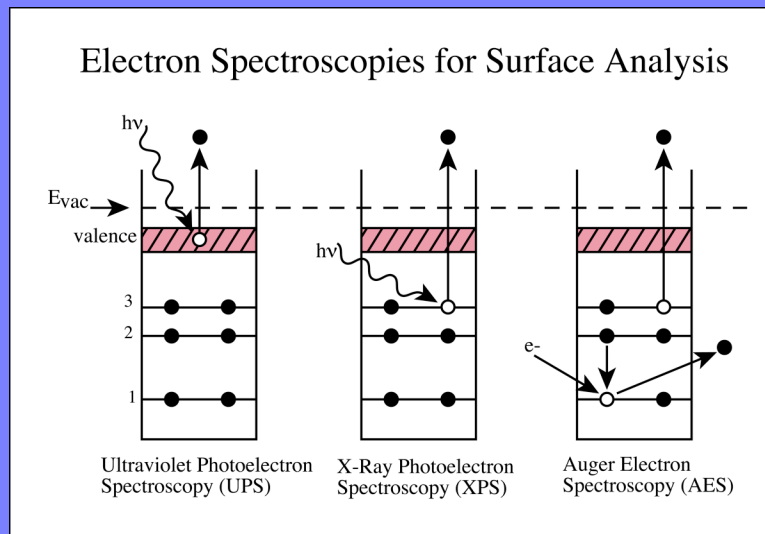
## Self-Assembled Monolayers

**Applications:** Corrosion protection, biomimicry, tailoring of wetting properties of surfaces, chemical sensors, modification of electrodes for organic electronics, molecular electronics, nanotemplating/nanomanufacturing.



**Figure 8.** Mass uptake change as a function of immersion time of a quartz crystal microbalance in 1 mM 2-(3-thienyl)ethanethiol ( $\Delta$ ), 6-(3-thienyl)hexanethiol ( $\blacksquare$ ), and 12-(3-thienyl)dodecanethiol ( $\circ$ ) solutions. The lines through the data are included to guide the eye. Note that the measurements were performed ex situ, as discussed in the text.

# Electron Spectroscopies



The photoelectron intensity ( $I$ ) emitted at an angle  $\theta$  relative to the surface plane, from depths less than  $d$ , is given by:

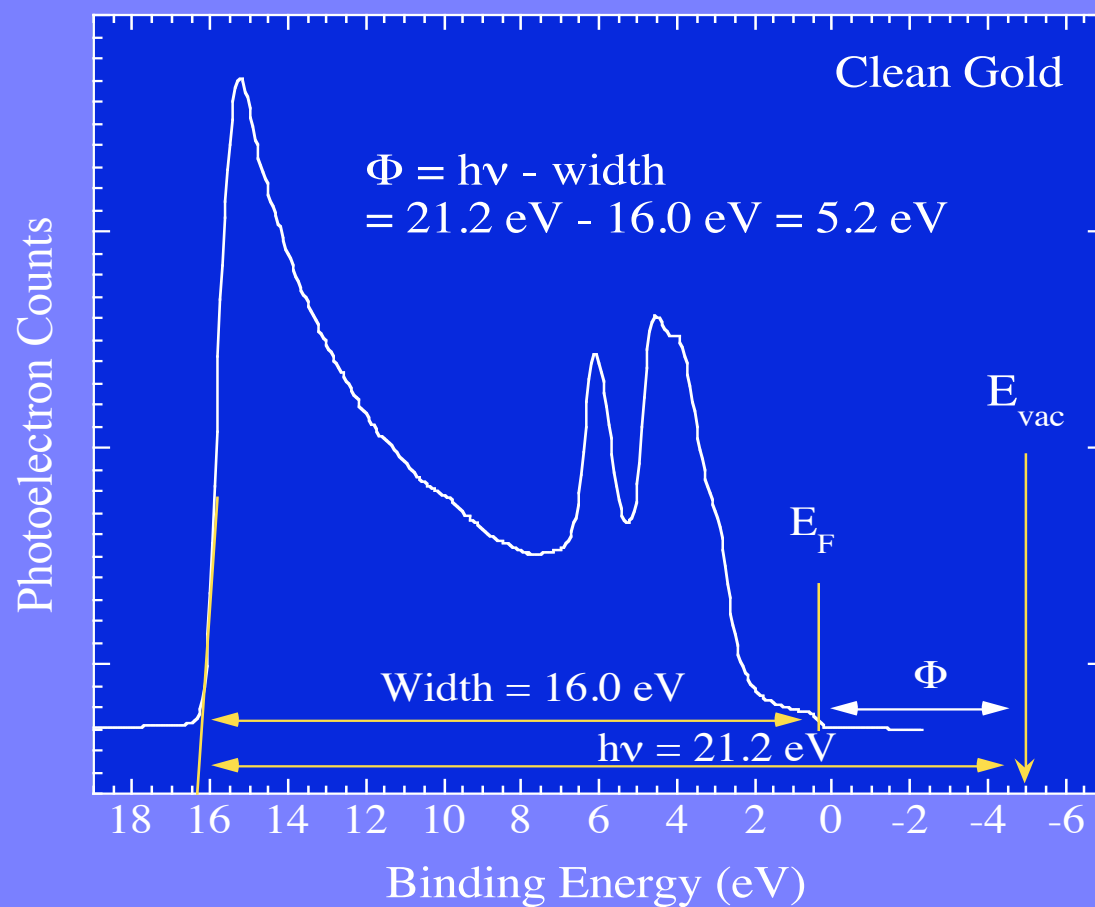
$$I = I_0 \exp \{-d/(\lambda \cos (90 - \theta))\}$$

where  $I_0$  is the intensity from an infinitely thick, uniform substrate and  $\lambda$  is the mean free path.

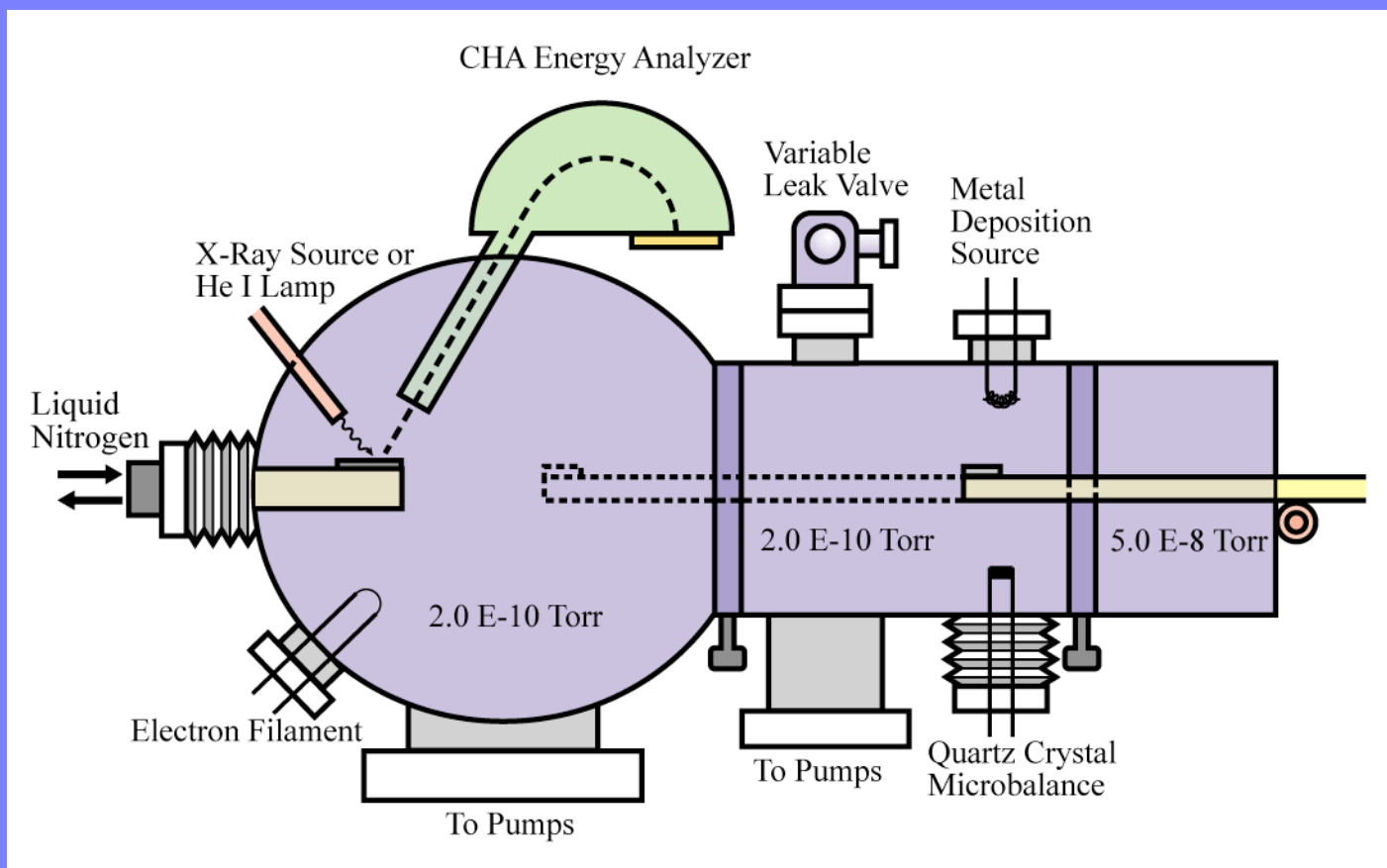
95% of the signal originates from a depth less than  $3\lambda$ .

## Ultraviolet Photoelectron Spectroscopy

The Work Function of a Sample Can be Calculated from the Width of the UPS Spectrum



# Experimental Apparatus



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## Topics to be Discussed

- Using thiol SAMs to pattern polymers, biomaterials, and conjugated oligomers.
- Comparison of thermal stability of thiol and silane monolayers.
- Sandwich structures using a mercaptosilane.
- Light-switchable functionalization for nanomanufacturing.

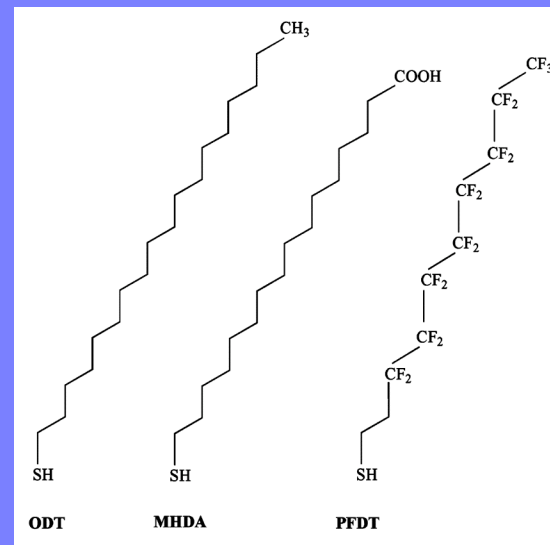
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## Template-Directed Patterning of Materials

❖ The goal is to use self-assembly of alkanethiols as templates for materials that are not easily patterned by other means.

❖ Microcontact printing and dip-pen nanolithography are used to form patterned arrays of alkanethiol monolayers on gold surfaces.

❖ The arrays of patterned alkanethiols affect the wetting properties of the surface so that spin-coated material selectively wets or de-wets the alkanethiol patterns.



**Table 1. Properties of Alkanethiol-Covered Gold Surfaces and These Surfaces after Spin-Coating PE-*b*-PEO Block Copolymers onto Them (Without Annealing)**

alkanethiol	$\theta$ (adv) water	$\theta$ (rec) water	C/Au atomic ratio for 80/20 PEO/PE block <sup>a</sup>	C/Au atomic ratio for 20/80 PEO/PE block <sup>b</sup>
ODT	$113 \pm 1$	$97 \pm 3$	0.92	infinite
PFDT	$109 \pm 3$	$85 \pm 1$	12	49
MHDA	$74 \pm 3$	$40 \pm 2$	infinite	19

<sup>a</sup> The polymer was spin-coated using a 0.5 wt % solution in chloroform.

<sup>b</sup> The polymer was spin-coated using a 0.4 wt % solution in toluene (warm solution).

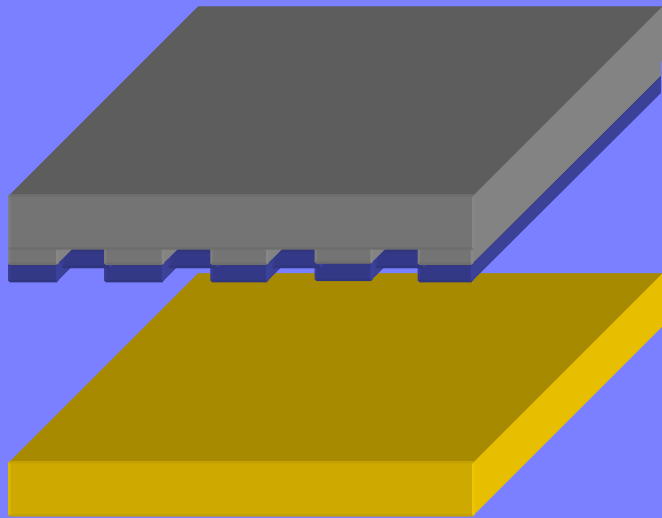


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# Microcontact Printing

**A technique that generates patterned self-assembled monolayers of alkanethiolates on metal surfaces (gold, silver and copper).**

- An "ink" of alkanethiols is spread on a patterned PDMS stamp.
- The stamp is then brought into contact with the substrate.
- The thiol ink is transferred to the substrate where it forms a self-assembled monolayer that can act as a resist against etching.

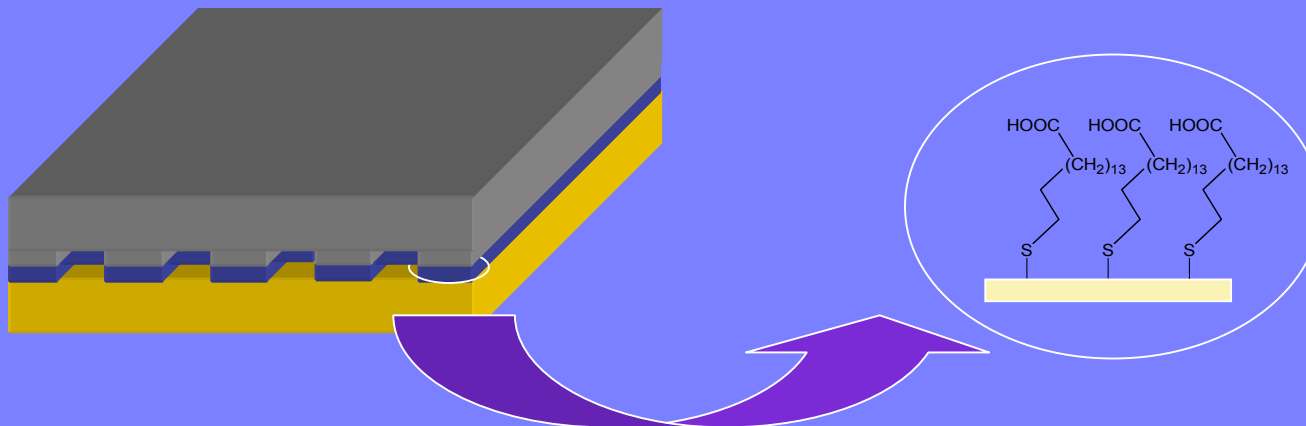


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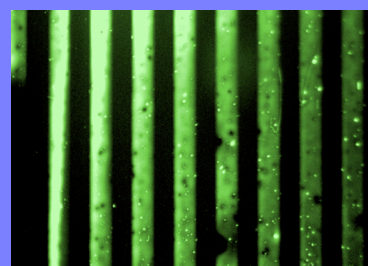
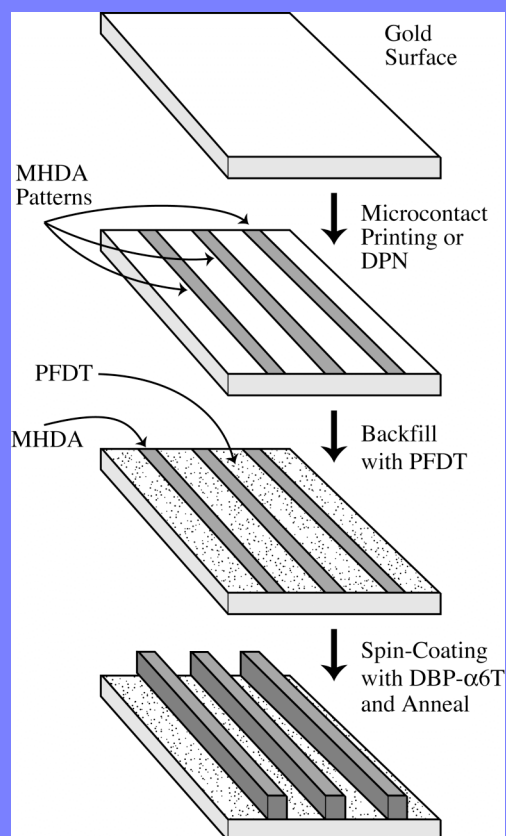
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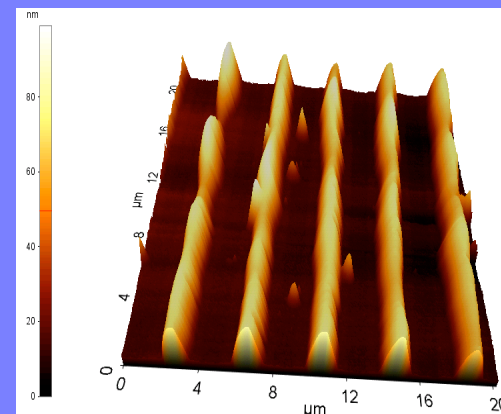
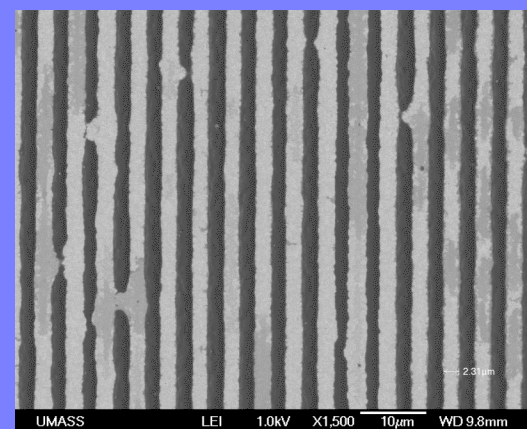
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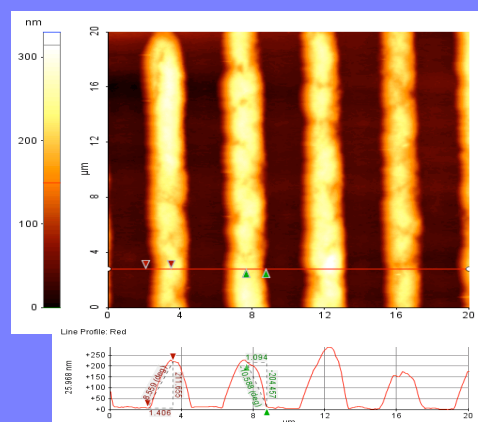
# Patterning of Conjugated Polymers and Biomaterials



Fluorescence Microscopy of Patterned Collagen-Fluorescein

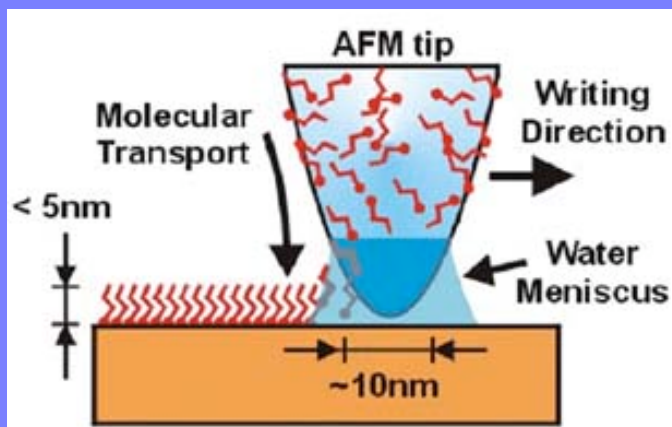


AFM and SEM Images of Patterned Poly-L-Tryptophan

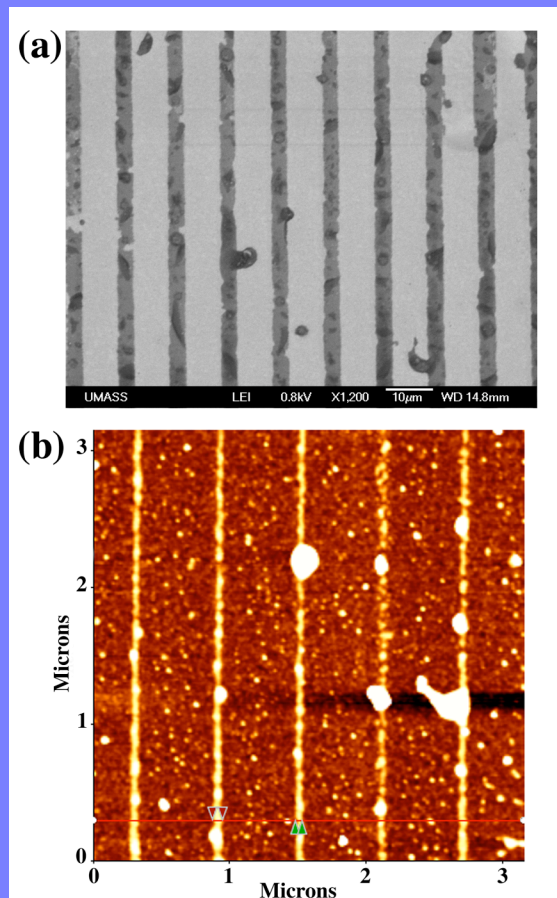
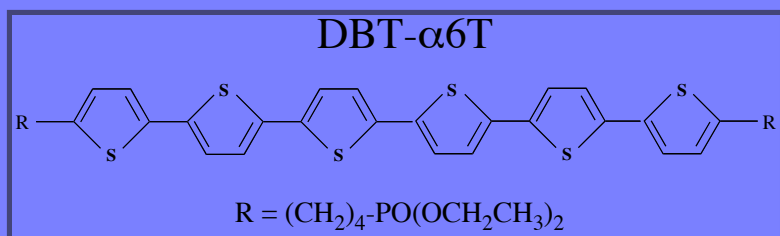


AFM of Patterned PEO-*b*-PE Polymer

# Use of Dip-Pen Nanolithography to Pattern a Conjugated Oligomer



<http://www.chem.northwestern.edu/~mkngrp/dpn.htm>



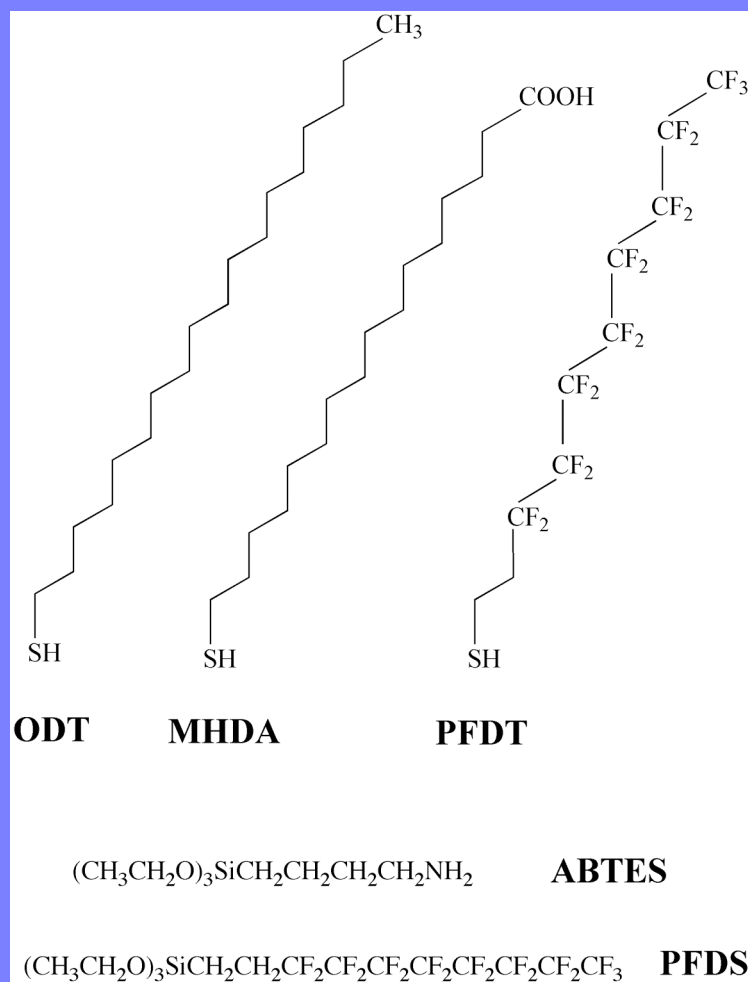
A. Chandekar and J.E. Whitten, *Appl. Phys. Lett.*, 2007, 91, 113103

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## Topics to be Discussed

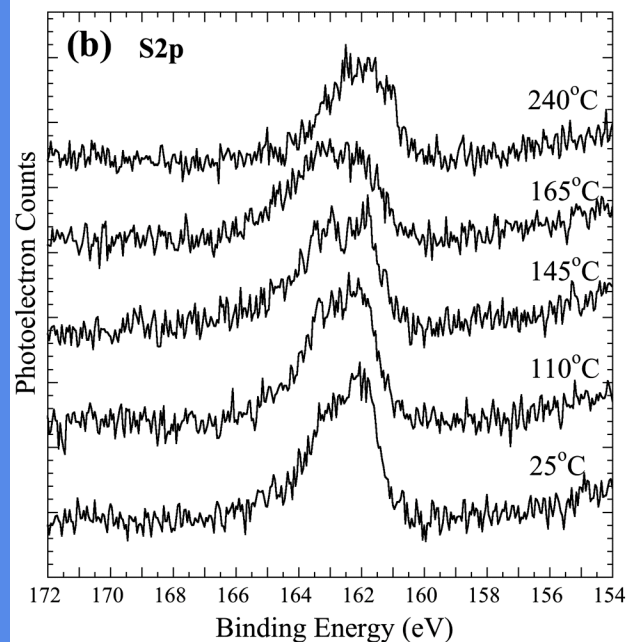
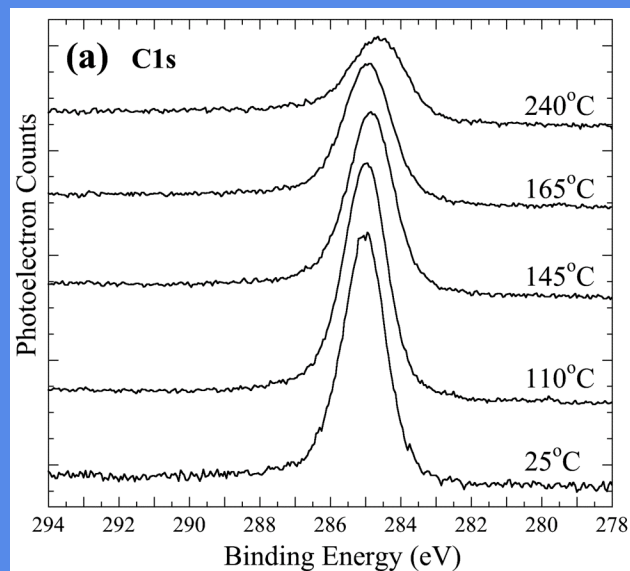
- Using thiol SAMs to pattern polymers, biomaterials, and conjugated oligomers.
- Comparison of thermal stability of thiol and silane monolayers.
- Sandwich structures using a mercaptosilane.
- Light-switchable functionalization for nanomanufacturing.

# Thermal Stability of Silane SAMs on Silicon Oxide/Si(111)



A. Chandekar, S.K. Sengupta, J.E. Whitten, *Appl. Surf. Sci.*, 2010, 256, 2742.

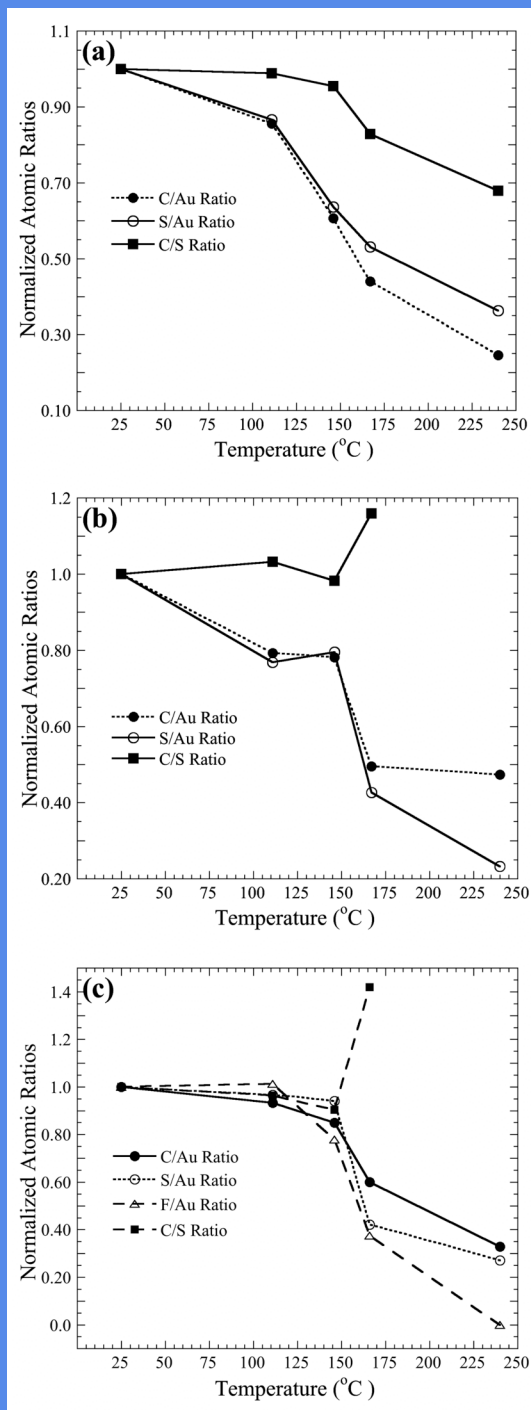
# XPS of Heating of ODT/Au(111) SAM



ODT

MHDA

PFDT



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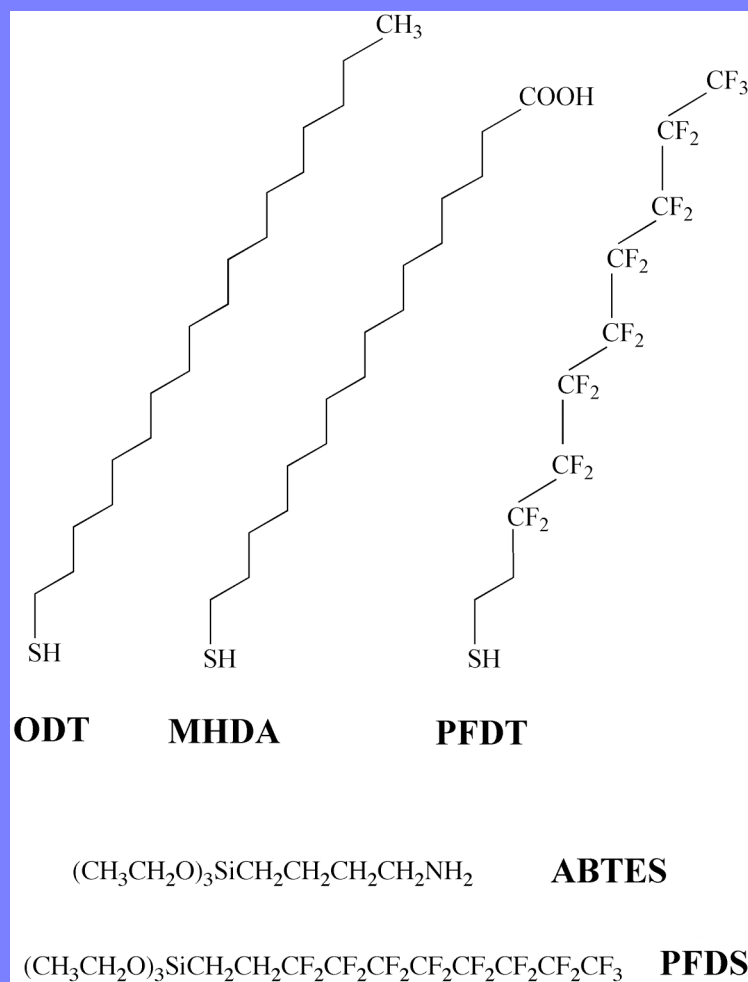
## Preparation of Silane Monolayers

Si(111) substrates were:

- Ultrasonicated in methanol and acetone and then etched in piranha solution at 80°C for 30 min. This procedure removes the native oxide and grows a fresh hydroxylated surface.
- Soaked in DI water to remove residual acid.
- Exposed to UV-ozone using a Novascan PSD-UV cleaner for 20 min to produce a clean, hydroxylated surface for silanization.
- Immersed in 1 mM silane solution in anhydrous hexane for 16 hr.
- Rinsed with anhydrous hexane.

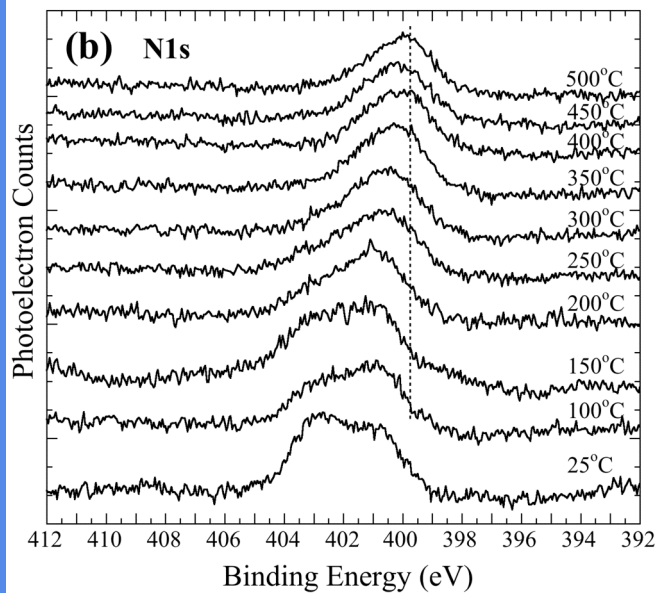
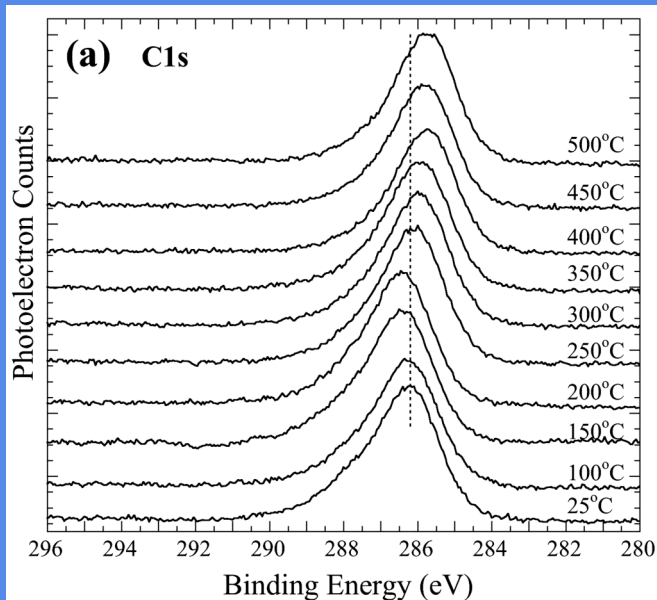


# Thermal Stability of Silane SAMs on Silicon Oxide/Si(111)

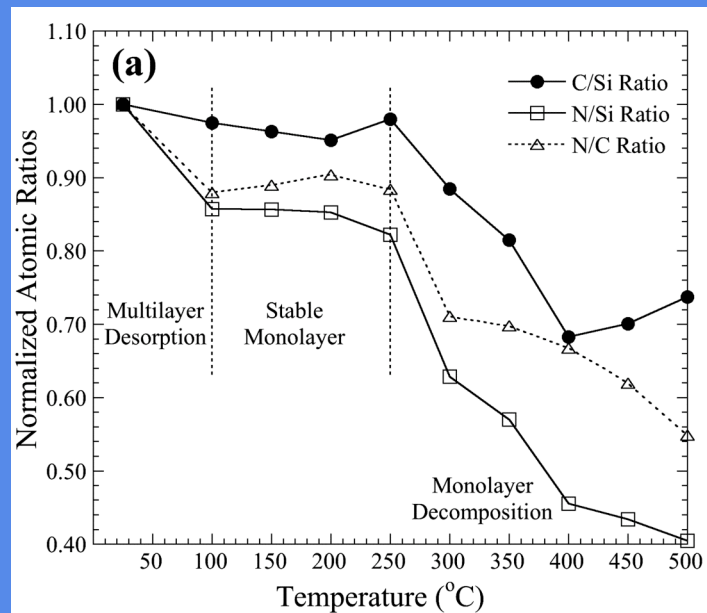


A. Chandekar, S.K. Sengupta, J.E. Whitten, *Appl. Surf. Sci.*, 2010, 256, 2742.

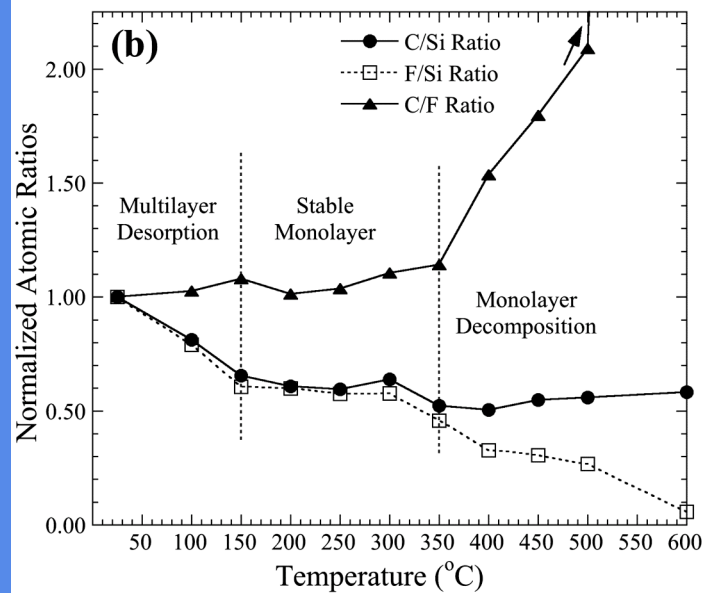
## XPS of Heating of ABTES/Si(111) SAM



ABTES



PFDS

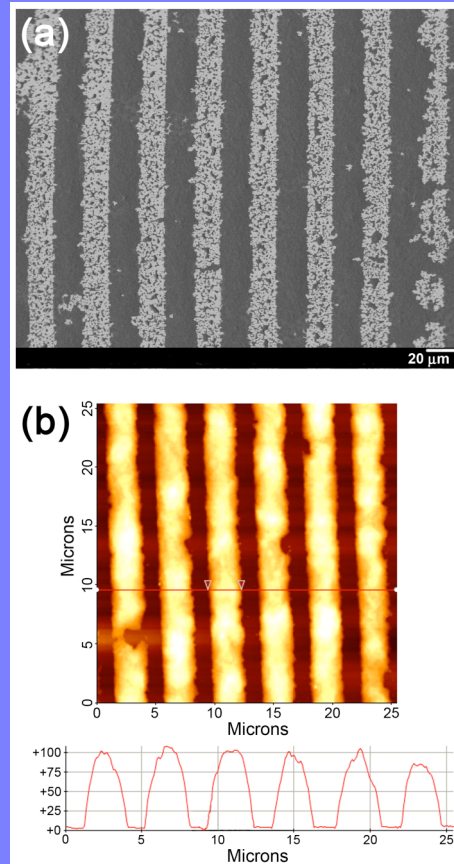


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## Conclusions

Monolayer/Surface	Decomposition Onset
ODT/Au	110 - 145°C
MHDA/Au	145°C
PFDT/Au	145-165°C
ABTES/Si	250°C
PFDS/Si	350°C

## Silane-Directed Patterning



(a) FE-SEM and (b) AFM images of the surface that results when a PFDS microcontact-printed hydroxylated  $\text{SiO}_2$  sample is spin-coated with a PEO/PE block copolymer and annealed for 2 hr at  $90^\circ\text{C}$ . Included with the AFM image is the cross sectional topographical height scale for the image. The units on the y-axis of the height scale are nanometers.

A. Chandekar, S.K. Sengupta, J.E. Whitten, *Appl. Surf. Sci.*, 2010, 256, 2742.

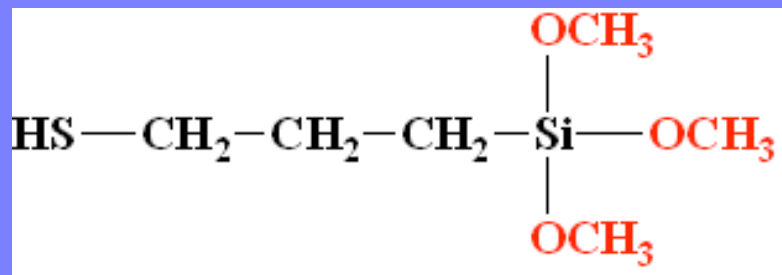
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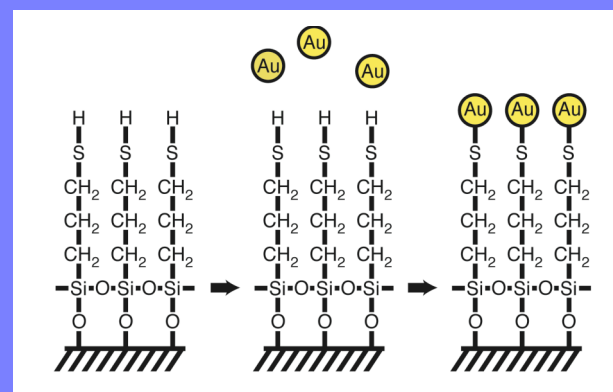
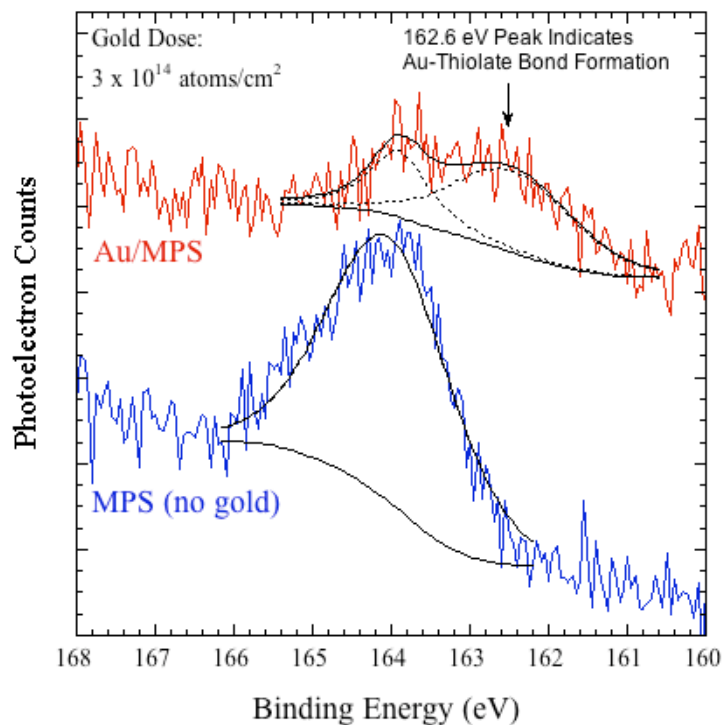
## An Interesting Molecule



3-Mercaptopropyltrimethoxysilane (MPS)

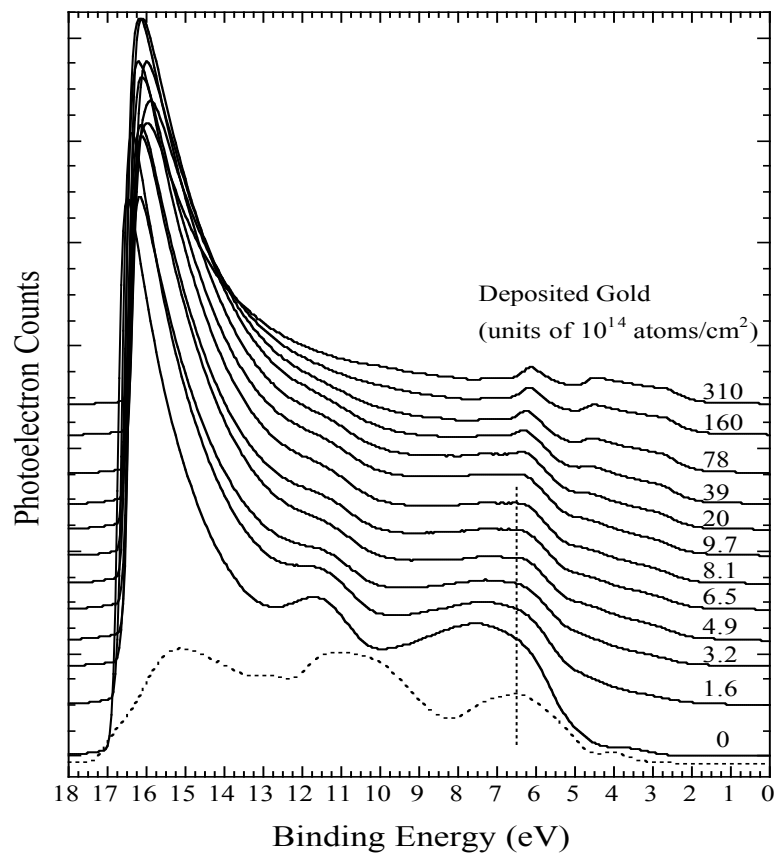
## XPS Confirms Bond Formation for Gold Deposited on MPS

MgK $\alpha$  XPS Spectra of the S 2p Region for Gold Deposited on 3-Mercaptopropyltrimethoxysilane (MPS) Films

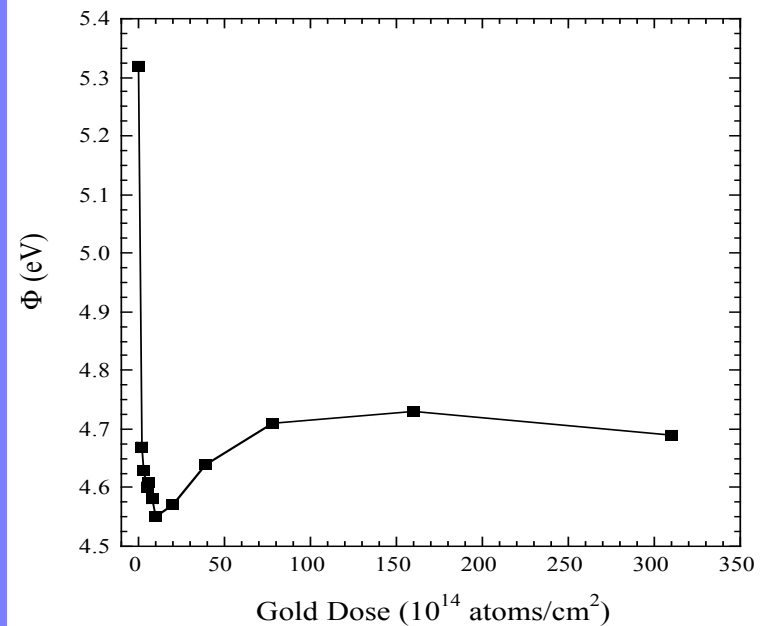


- Angle-resolved XPS shows that gold stays on top of the MPS film.
- Possibilities of molecular electronic devices (e.g., capacitors).

## UPS of Gold Deposition on MPS



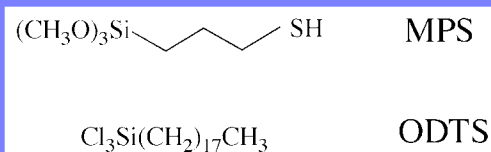
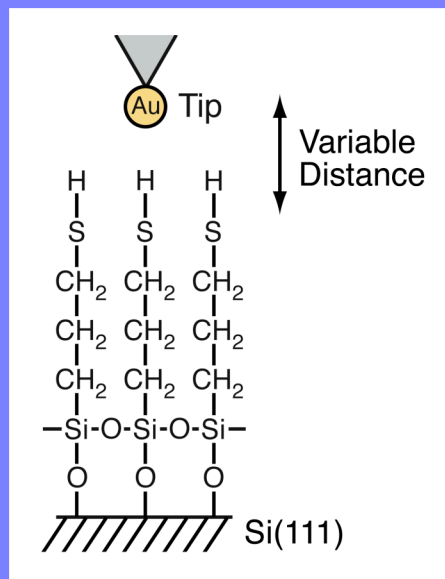
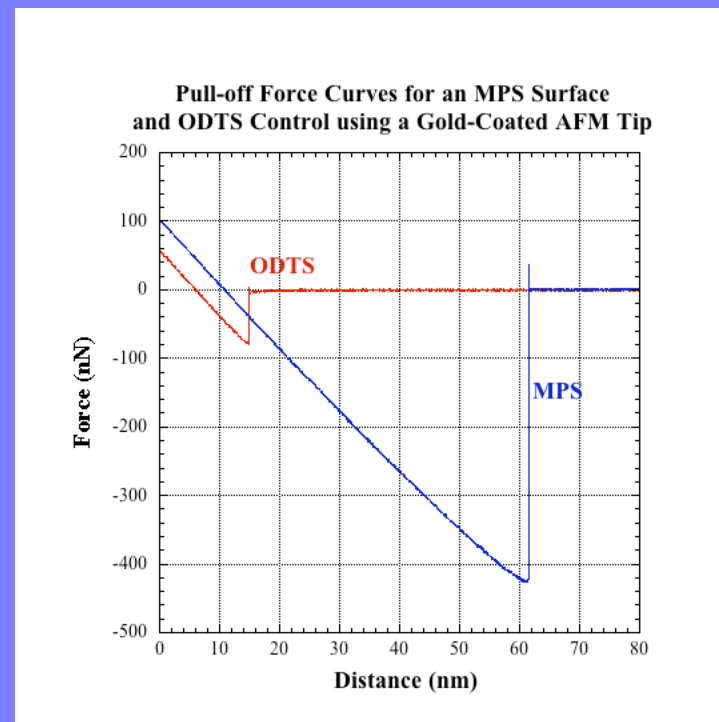
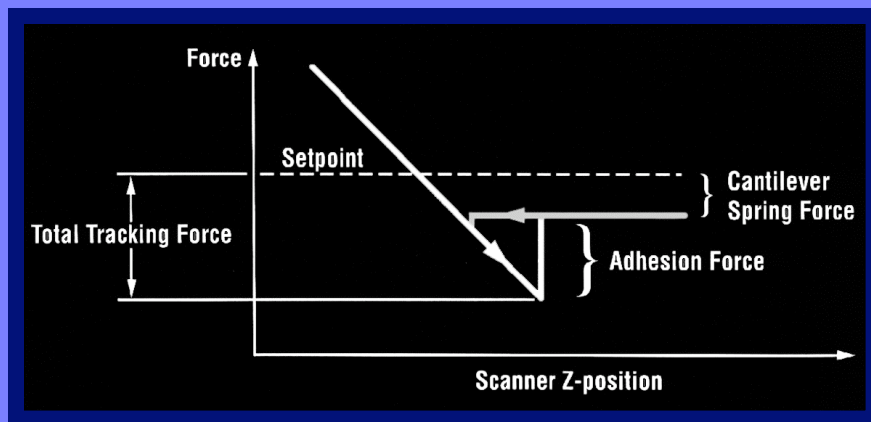
## Work function vs. Gold Coverage



➤ Final work function value indicates gold not in electronic contact with substrate.



# Force-Distance Measurements



Summary of Jump-In and Pull-Off AFMS studies for Gold-Coated Tips and Silane Films

Silane System	Mean Jump-In Force (nN)	Mean Pull-Off Force (nN)
Octadecyltrichlorosilane	133 +/- 46	107 +/-25
Mercaptopropyltrimethoxysilane	340 +/- 86	409 +/-48

J. Singh, J.E. Whitten, *J. Phys. Chem. C*, 2008, 112, 19088.

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## Conclusions

- Patterning of a wide variety of materials may be achieved if a sufficient contrast in wetting properties is obtained on the surface by chemical modification (e.g., thiol or silane SAMs).
- Silane SAMs on silicon oxide surfaces are substantially more thermally stable than thiol SAMs on metal surfaces.
- Light may be used on photocatalytic surfaces (e.g,  $\text{TiO}_2$ ) to induce hydrophilicity - believed to be due to decomposition/desorption of hydrocarbons. Photomasking can be used to achieve contrast in hydrophobicity and patterning.
- Light switchable functionalization is being pursued for nanotransfer applications.

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## Acknowledgements

Dr. Heejoon Ahn

Dr. Amol Chandekar (patterning work, thermal stability)

Sandip Sengupta

Dr. Jagdeep Singh (MPS studies, titanium dioxide)

Collaborators (CHN, UML): Profs. Carol Barry and Joey Mead



-The National Science Foundation

-NSF Center for High-Rate Nanomanufacturing

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